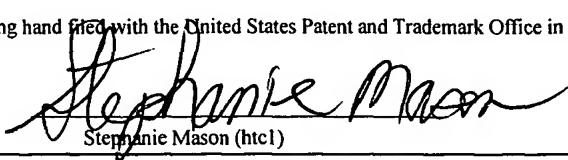




PATENT
Docket No. 204552029200

CERTIFICATE OF HAND DELIVERY

I hereby certify that this correspondence is being hand delivered with the United States Patent and Trademark Office in Alexandria, Virginia on September 25, 2003.



Stephanie Mason

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Shinichi NAGAHAMA et al.

Serial No.: 10/614,342

Filing Date: July 8, 2003

For: NITRIDE SEMICONDUCTOR DEVICE
COMPRISING BONDED SUBSTRATE
AND FABRICATION METHOD OF
THE SAME

Examiner: To be assigned

Group Art Unit: To be assigned

**INFORMATION DISCLOSURE
STATEMENT UNDER 37 CFR 1.97 & 1.98**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.97 and 1.98, Applicants submit for consideration in the above-identified application the documents listed on the attached Form PTO-1449. Copies of the documents are also submitted herewith. The Examiner is requested to make these documents of record.

This Information Disclosure Statement is submitted within three months of the filing date; accordingly, no fee or separate requirement is required.

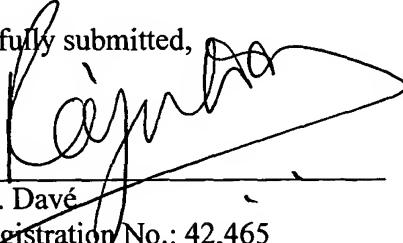
Reference Nos. 1-2, 8-27, 46 and 48 were cited in the International Search Report of WO03/34508 (Ref. No. 47). Reference Nos. 3-4, and 30-34 were cited in the International Search Report of PCT/JP03/00757.

Applicants would appreciate the Examiner initialing and returning the Form PTO-1449, indicating that the information has been considered and made of record herein.

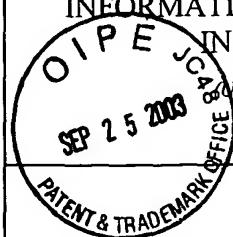
The information contained in this Information Disclosure Statement under 37 CFR 1.97 is not to be construed as a representation that: (i) a complete search has been made; (ii) additional information material to the examination of this application does not exist; (iii) the information, protocols, results and the like reported by third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

In the event that the transmittal letter is separated from this document and the Patent and Trademark Office determines that an extension and/or other relief is required, applicants petition for any required relief including extensions of time and authorizes the Commissioner to charge the cost of such petitions and/or other fees due in connection with the filing of this document to **Deposit Account No. 03-1952** referencing 204552029200. However, the Commissioner is not authorized to charge the cost of the issue fee to the Deposit Account.

Dated: September 25, 2003

Respectfully submitted,

By: _____
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Form PTO-1449

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

Docket Number 204552029200	Application Number 10/614,342
Applicant	Shinichi NAGAHAMA et al.
Filing Date July 8, 2003	Group Art Unit To be assigned
Mailing Date September 25, 2003	

U.S. PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Name	Class	Subclass	Filing Date If Appropriate
	1.	9/28/1999	5,959,316				
	2.	8/23/2001	2001-015443				
	3.	8/30/2001	2001-017874				
	4.	12/17/2002	6,495,862				
	5.	4/3/2003	2003-0062530				
	6.	11/22/2001	2001-0042866				

FOREIGN PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Country	Class	Subclass	Translation YES NO
	7.	1/12/2001	JP 2001-007394	*			X
	8.	3/30/2001	JP 2001-085747	*			X
	9.	10/24/2000	JP 2000-299503	*			X
	10.	2/25/1992	JP 4-057329	*			X Abstract
	11.	1/14/1992	JP 4-010418	*			X Abstract
	12.	7/31/2001	JP 2001-206710	*			X
	13.	1/13/1977	JP 52-004175	*			X Abstract
	14.	1/19/2001	JP 2001-015817	*			X
	15.	3/14/2000	JP 2000-077723	*			X Abstract
	16.	3/31/1995	JP 7-086640	*			X
	17.	2/5/1993	JP 5-029663	*			X
	18.	7/14/2000	JP 2000-196141	*			X Abstract
	19.	9/18/2001	JP 2001-253294	*			X
	20.	7/19/2001	JP 2001-196645	*			X
	21.	7/27/2001	JP 2001-203392	*			X
	22.	12/10/1999	JP 11-340518	*			X Abstract
	23.	10/13/1995	JP 7-263553	*			X

EXAMINER:

DATE CONSIDERED:

EXAMINER: Initial if citation considered, whether or not the citation conforms with MPEP 609. Draw a line through the citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

<p>Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)</p>		Docket Number 204552029200		Application Number 10/614,342	
		Applicant			
		Shinichi NAGAHAMA et al.			
		Filing Date July 8, 2003		Group Art Unit To be assigned	
Mailing Date September 25, 2003					

24.	8/6/1993	JP 5-198689	*	/	X	
25.	6/15/1999	JP 11-506872	*	/	X Abstract	
26.	5/6/1998	JP 10-117016	*	/	X	
27.	1/10/1997	UP 9-008403	*	/	X	
28.	5/16/1997	JP 9-129932	*	/	X	
29.	11/9/2001	JP 2001-313422	*	/	X	
30.	10/26/2001	JP 2001-298214	*	/	X Abstract	
31.	7/14/2000	JP 2000-196152	*	/	X Abstract	
32.	8/6/1999	JP 11-214744	*	/	X	
33.	10/12/2001	JP 2001-284641	*	/	X	
34.	8/14/1986	JP 61-182292	*	/	X Abstract	
35.	7/21/1975	JP 50-091292	*	/		X
36.	11/14/1983	JP 58-195276	*	/	X Abstract	
37.	8/14/1986	JP 61-182256	*	/	X Abstract	
38.	8/19/1994	JP 6-232510	*	/	X	
39.	8/16/1986	JP 61-183986	*	/	X Abstract	
40.	1/14/1986	JP 61-007671	*	/	X Abstract	
41.	1/31/1992	JP 4-029374	*	/	X Abstract	
42.	3/3/2000	JP 2000-067673	*	/	X	
43.	3/27/1986	JP 61-059886	*	/	X Abstract	
44.	6/10/2000	JP 2000-277804	*	/	X	
45.	8/15/2000	JP 2000-228537	*	/	X Abstract	
46.	12/20/2000	EP 1 061 590	EPO		X	
47.	4/24/2003	WO 03/34508	PCT		X	
48.	1/3/1997	WO 97/00535	PCT		X	

OTHER DOCUMENTS

(including author, title, Date, Pertinent Pages, Etc.)

Examiner Initials	Ref. No.	Title
	49.	Morita et al. "High Output Power 365nm Ultraviolet Light Emitting Diode of GaN-Free Structure", Jpn. J. Appln. Phys. Vol. 41, Part 2, No. 12B 12/2002, pp. L1434-L1436.

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